PROCESS CP707

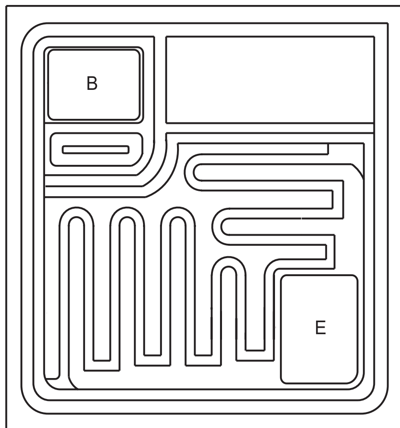
Small Signal Transistor

PNP - Darlington Transistor Chip

PROCESS DETAILS

Process	EPITAXIAL PLANAR
Die Size	27 x 27 MILS
Die Thickness	9.0 MILS
Base Bonding Pad Area	5.3 x 3.8 MILS
Emitter Bonding Pad Area	5.3 x 6.5 MILS
Top Side Metalization	Al - 30,000Å
Back Side Metalization	Au - 18,000Å

GEOMETRY



BACKSIDE COLLECTOR

GROSS DIE PER 4 INCH WAFER

15,165

PRINCIPAL DEVICE TYPES

CMPTA63
CMPTA64
CXTA64
CZTA64
MPSA63
MPSA64

145 Adams Avenue
Hauppauge, NY 11788 USA
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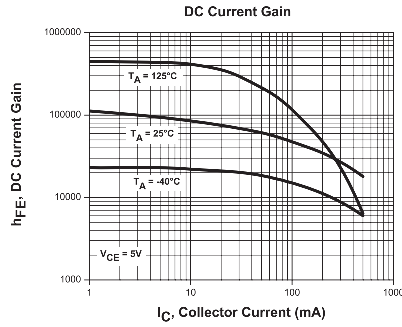
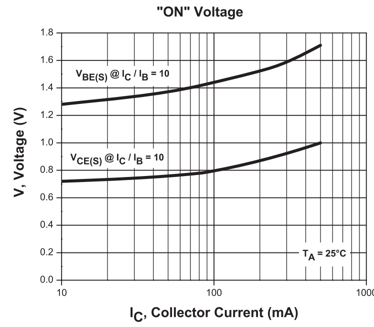
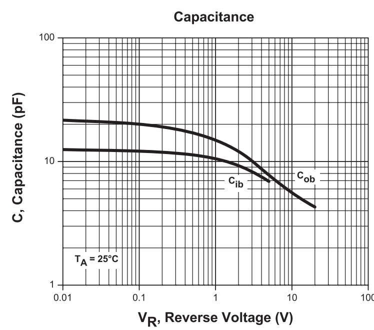
Central Semiconductor Corp.

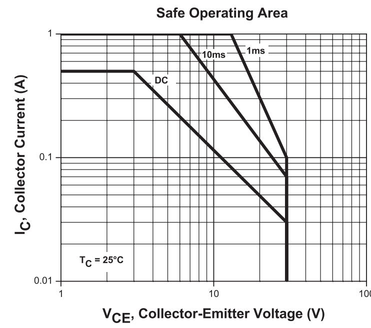
PROCESS CP707

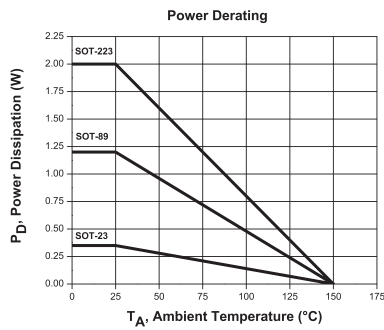
Typical Electrical Characteristics

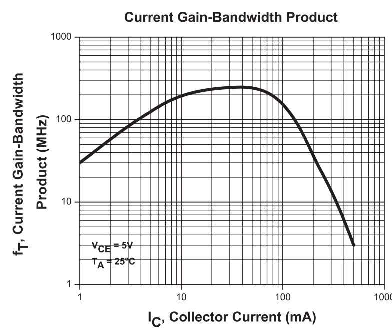












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